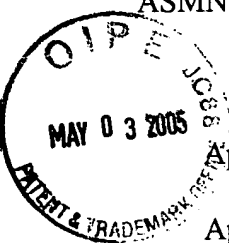


IFW

ASMNUT.008CP1

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Komandur et al.
App. No. : 10/697,199
Filed : October 31, 2003
For : DISTRIBUTED CONTROL
SYSTEM FOR
SEMICONDUCTOR
MANUFACTURING
EQUIPMENT
Examiner : Karla A Moore

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

April 29, 2005

(Date)

Tina Chen, Reg. No. 44,606

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Our file for the above-identified application reveals that there has been no action taken since the application was filed, i.e. October 31, 2003. Please inform us as to the status of this application.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: April 29, 2005

By: [Signature]
Tina Chen
Registration No. 44,606
Attorney of Record
Customer No. 20,995
(415) 954-4114